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	Filing Date		2006-06-02	
	First Named Inventor	Takayuki Shima		
	Art Unit	2627		
	Examiner Name			
Attorney Docket Number		690121.407USPC		

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1	Neff, H. et al., "Structural, optical, and electronic properties of magnetron-sputtered platinum oxide films", Journal of Applied Physics, American Institute of Physics. New York, US, vol. 79, no. 10, 15 May 1996, pages 7672-7675, XP002463986.	<input type="checkbox"/>
2	Yi Chiu et al., "Fabrication and nonlinear optical properties of nanoparticle silver oxide films", Journal of Applied Physics, vol. 94, no. 3, 1 August 2003, pages 1996-2001, XP002479469.	<input type="checkbox"/>

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